



EUROPEAN  
SPALLATION  
SOURCE



# Sample environment for Imaging and Engineering instruments

Update

PRESENTED BY CAROLINE CURFS

2025-09-26

# Agenda



- 1 Mechanical processing
- 2 Furnaces
- 3 Users SES



### **PhD at ESRF (Materials Science Beamline ID11), France/instituto de Ceramica y Vidrio, Spain**

- Time resolved diffraction, fast phase transformations, metastable phase
- Al, Ni, Ti, C system

### **Post-doc at ANSTO, Australia**

- Installation and commissioning of the strain scanner at HiFAR,
- Building Australian neutrons RS community

### **ASRP fellow at the University of Newcastle, Australia**

- Time resolved diffraction with neutron and synchrotron sources

### **Post doc at ESRF (Materials science beamline ID11), France**

- Commissioning of the ID11 Extension (3DXRD)
- Support of users mainly for in-situ/operando diffraction experiments

### **Scientist at ESRF (Powder diffraction beamline ID31/ID22), France**

- HR residual stress measurements and in situ diffraction
- Steel and Shape memory alloys

### **Researcher at CEA for theNanoelectronic IRT programme**

- Construction and commissioning of a reflectometer at ESRF, BM05
- Industrial users experiments microelectronic

### **Industrial liaison scientist at HZG, Germany**

- Various diffraction experiments for industrial users (experiment, data reduction, analysis and reporting) including:
  - Residual stress measurements with conical slits
  - In situ measurements with dilatometer
- Commissioning of a 3DXRD



**1**

# **Mechanical processing**

# NPI stress rig

MEC-002

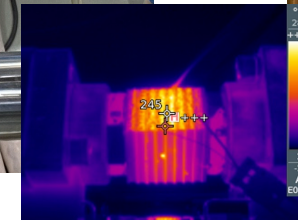
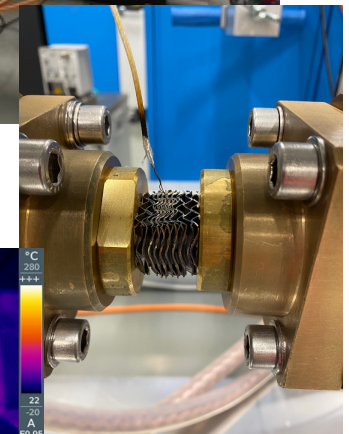
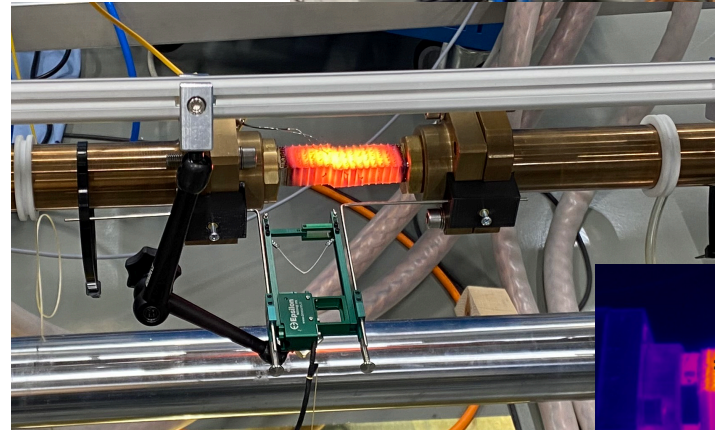
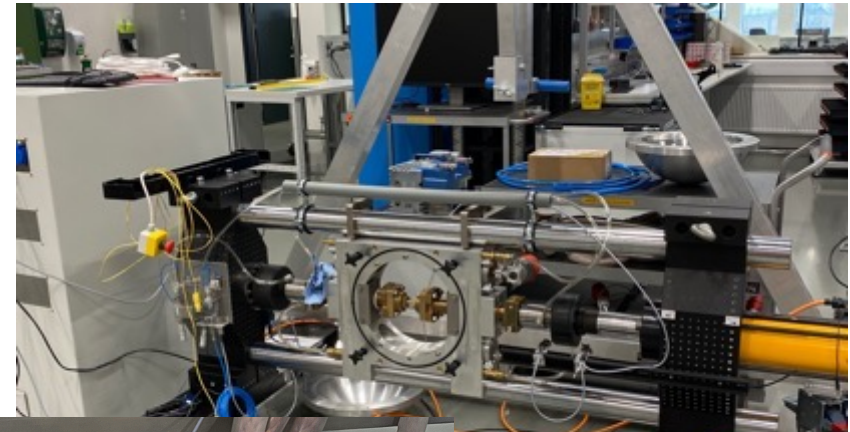


## Main specifications:

- 40/60 kN uniaxial deformation rig
- Compression and tension
- Body up to 100 kN
- Heating possible by conductive heating
- Cooling grips
- Chamber for inert atmosphere and vacuum
- For BEER

## Status:

- In tests
- Control integration nearly finished
- Mechanical integration in design
- New grips: conceptual design on going



# Torsion/rotation rig

MEC-005

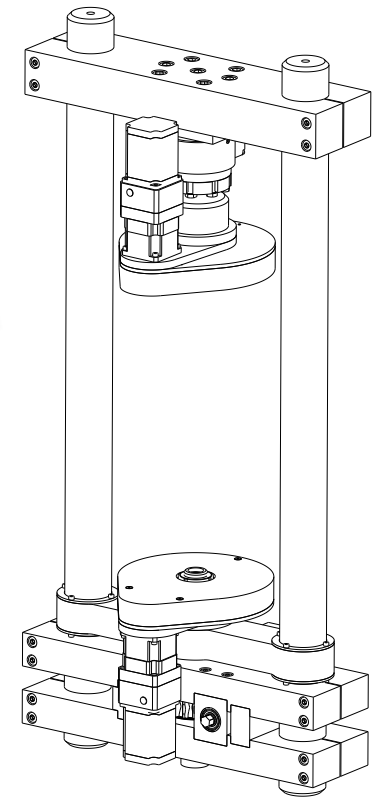
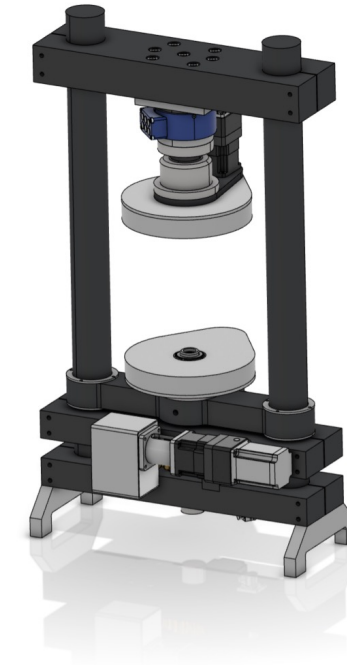


## Main specifications:

- 40 kN deformation rig
- Uniaxial and torsion deformation
- Sample rotation for tomography

## Status:

- Off-the-shelf parts purchased
- Manufacturing in progress (planned to be finished 11/25)
- Electronic control box nearly finished – waiting for rig



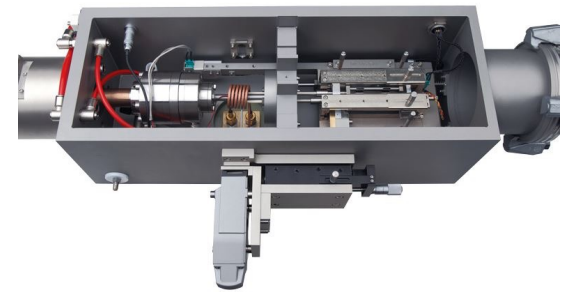
# Dilatometer

MEC-001



## Main specifications:

- For thermo-mechanical testing
  - Precise measurement of deformation versus temperature
- Can be used in and out of the beam
- Induction heating
- Can include tension or/and compression deformations
- Quenching option
- Exact specifications to be determined



## Status:

- Definition of specifications
- Meetings with potential suppliers





# Other mechanical processing SES

## MEC-003 and MEC-004



### **MEC-003:** 5-10 kN uniaxial stress rig

- For soft matter
- Can be used on ODIN
- Project start > 2027



### **MEC-004:** Gleeble (physical simulation)

- Public-Private Partnership
- Can be used out of the beam and in the beam
- Project start > 2027





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# **Furnaces**

# Vacuum furnaces

## HTP-001 & HTP-002



### Main specifications:

- Vacuum furnaces
- Niobium (HTP-001) : up to 1600 C
- Vanadium (HTP-002): up to 1000 C

### Status:

- HTP-001: waiting for transfer from LLB
- HTP-002: Quotation received but above budget – Other options in discussion
- Control trolley in discussion



# Induction furnace

HTP-004

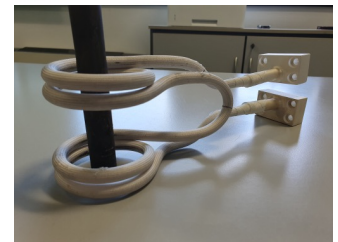
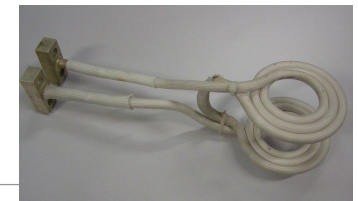


## Main specifications:

- For conductive samples between 8 and 15 mm of diameter
- Standalone or with a deformation rig (torsion/rotation or uniaxial)
- Maximum temperature depends on the sample ( $> 2000^{\circ}\text{C}$ )
- High cooling and heating rates
- Can be used in air or in a chamber
- Different coil geometries possible
- 12 kW / 30-60kHz

## Status: In development

- Procurement of induction system on going (waiting for delivery)
- Control by eurotherm with pyrometers (specification TBD)



# UHT furnace

## HTP-005

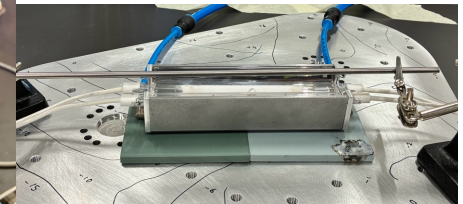
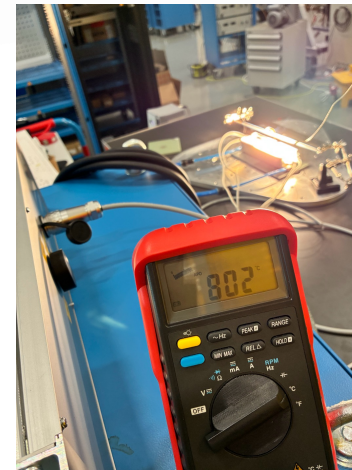
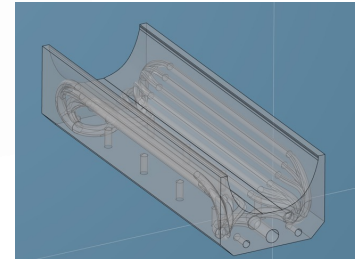
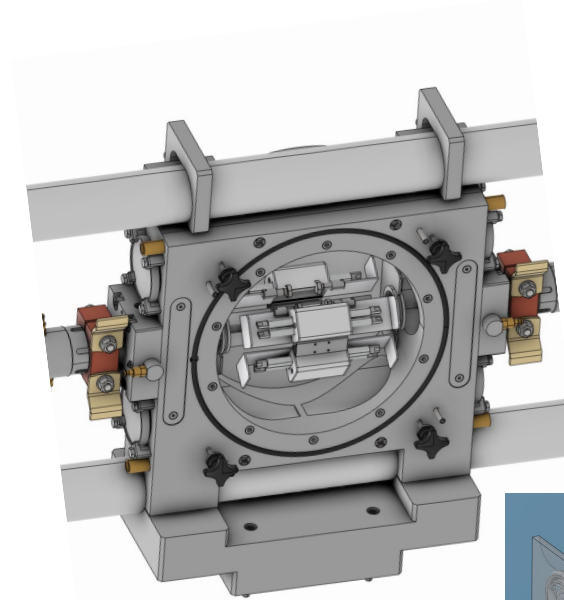


### Main specifications:

- Chalmers/ISIS VR project
- Short wave IR lamp furnace based on ENGIN-X lamp furnace
- Planned to go up to 1800C
- In vacuum, inert atmosphere or air (max temp TBD)
- Adaptable to NPI stress rig or standalone

### Status: In development

- 3D printed reflectors with enhanced cooling designed and successfully tested
- Bulbs: in discussion with manufacturer to improved version
- Electronics on going
- Tests with new reflector + ISIS bulbs + electronic successful



With half power

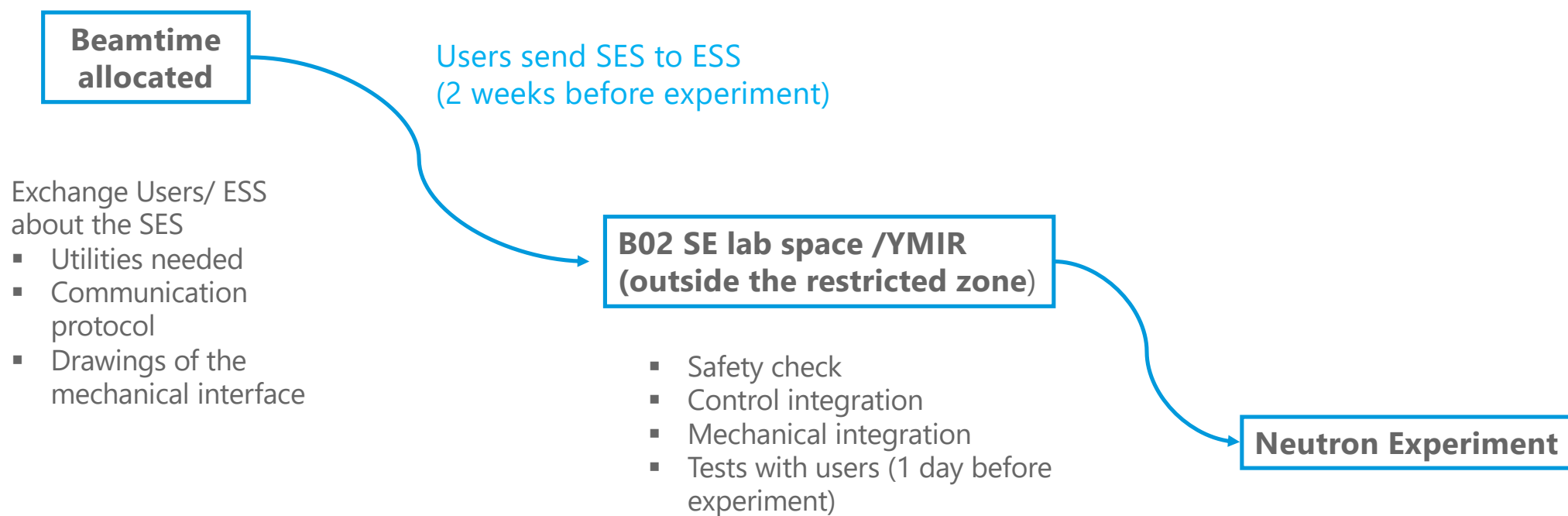


**3**

# **Users sample environment systems**

# Users SE

## Process

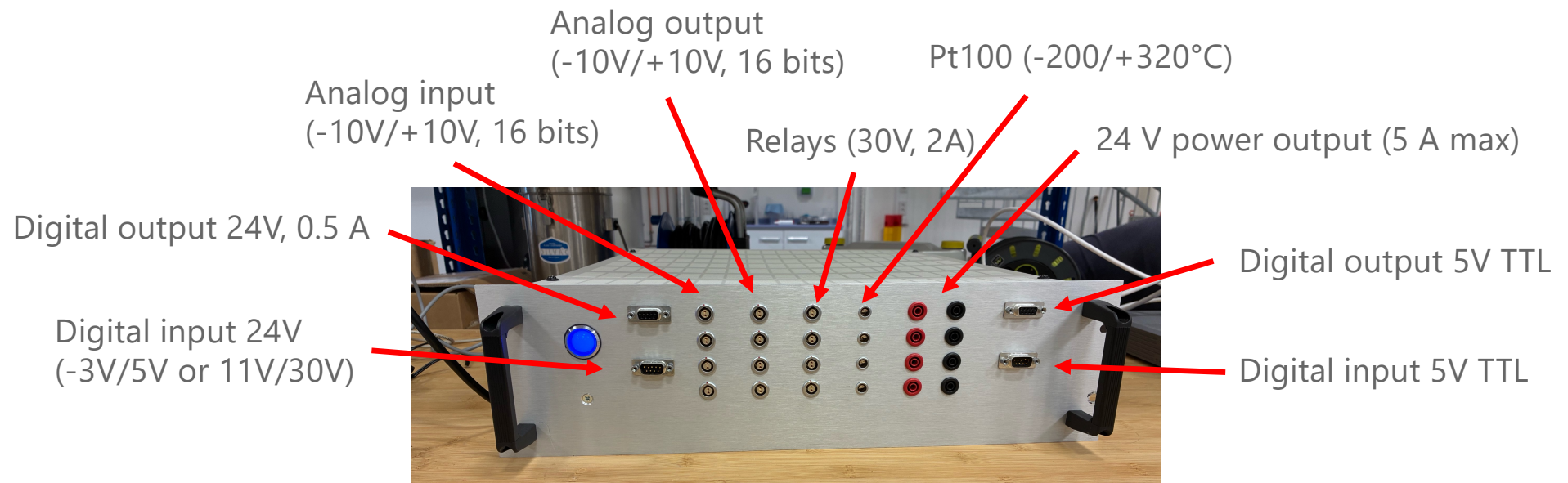


# MacGyver Box

## Multi-purpose I/O box for generic use



- Beckhoff PLC + modules
- Integrated into EPICS via Octopy running on IPC
- Can be custom-made







# Finish presentation